FORM PTO-1449		U.S. Department of Commerce Patent and Trademark Office			Atty. Doc P29123	ket No.		Application No. 10/569,942		
INF		Applicant Akihiko ENDO et al.								
(Use several sheets if necessary)					Filing Date September 1, 2004  Group 2812					:
U.S. PATENT DOCUMENTS										
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	ľ	NAME		SUBCLASS		FILING DATE IF APPROPRIATE	
							-			
							-			
FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBER	DATE	cou	NTRY	CLASS	SUB	CLASS	TRANSLATION YES NO	
		OTHER DOCUMENTS	S (Including Au	thor Title	Date Portin	ent Pages Et	c )			
/C INI /	1							n Sentem	her 6, 200	17 and
/S.J.N./		U.S. Patent Application No. 11/851,065 (NISHIHATA et al.), which was filed on September 6, 2007 and entitled, "BONDED WAFER AND METHOD OF MANUFACTURING THE SAME."								
EXAMINER	/Seah	vosh Nikmanesh/		DA	TE CONSI	DERED 07	/28/20	008		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with post communication to applicant.										